

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants: Date: February 14, 2008
Haight et al. Group Art Unit: 1793
Serial No.: 09/933,461 Examiner: Geoffrey S. Evans
Filed: August 20, 2001 Docket No.: YOR919980510US2
For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

1. This is a petition for an extension of time to respond to the Office Action dated November 2, 2007 for a period of 1 months.

2. Applicant is other than a small entity.

3. Extension: _____ Fee for other than
(months) small entity
[X] one month \$ 120.00
[] two months \$ 450.00
[] three months \$1,020.00

Fee: \$120.00

4. An Amendment

[X] is filed herewith
[] has been filed

5. Fee payment

[X] Charge fee to Deposit Account No. 09-0468 and for any additional extension fee required or credit any excess fee paid.

Respectfully submitted,

By: /Daniel P Morris
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